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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

Application Number	N/A-88 16/814 682
Filing Date	Herewith 3-31-04
First Named Inventor	Wen Lin, et al.
Art Unit	N/A-88 2893
Examiner Name	N/A
Attorney Docket Number	LIN 13-38

Sheet 1 of 2

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
JL		US- 4,378,259	03/29/1983	Hasegawa et al.	col 2, ln 32 - col 4, ln 65
		US-			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				

Examiner Signature	Rubio G. Maldonado	Date Considered	04/15/2005
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Application Number

NYA 10/8/4

Filing Date

Herewith

First Named Inventor

Wen Lin, et al.

Art Unit

NAK 382

Examiner Name

N/A

Attorney Docket Number

LIN 13-38

NON PATENT LITERATURE DOCUMENTS

**Examine
Initials***

Cite
No. 1

Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

 τ^2 

U.S. Serial No. 10/003,873 filed on October 24, 2001; entitled "SEMICONDUCTOR DEVICE HAVING A DOPED LATTICE MATCHING LAYER AND METHOD OF MANUFACTURE THEREFOR" to Wen Lin, et al.; Allowed January 13, 2004.

**Examiner
Signature**

Julius J. Maldonado

Date _____

Considered

04/15/2025

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